

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)

Liang, Ted et al.)

Application No.: Not yet assigned)

Filed: Herewith)

For: MASK REPAIR WITH
ELECTRON BEAM-INDUCED
CHEMICAL ETCHING)

Which is a Divisional of Application of:)

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D. C. 20231TERESA EDWARDS
(Typed or printed name of person mailing
paper or fee)Teresa Edwards
(Signature of person mailing paper or fee)September 10, 2003
(Date signed)**PRELIMINARY AMENDMENT**

Sir:

Applicants respectfully request that this Preliminary Amendment be entered prior to examination of the above-identified patent application.